## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Cristina Gomila et al. Art Unit: 2624

Filed: 22 February 2006 Examiner: Michelle M. Entezari

Serial No.: 10/569,318

For : METHOD AND APPARATUS FOR MODELING FILM GRAIN

PATTERNS IN THE FREQUENCY DOMAIN

## AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. 1.116(b)

Commissioner for Patents MAIL STOP AF P.O. Box 1450 Alexandria, Virginia 22313-1450

In response to the Official action mailed July 31, 2009, applicants request that they be allowed to the above-identified application to place it better condition for consideration.

Listing of the Claims begins of page 2

Remarks begin of page 5